
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Koos et al.

Attorney Docket No.:
NOVLP068/NVLS-2818

Application No.: 10/690,084

Examiner: Vinh, Lan

Filed: October 20, 2003

Group: 1765

Title: METHOD FOR FABRICATION OF
SEMICONDUCTOR INTERCONNECT
STRUCTURE WITH REDUCED CAPACITANCE,
LEAKAGE CURRENT, AND IMPROVED
BREAKDOWN VOLTAGE

Confirmation No.: 4873

CERTIFICATE OF FACSIMILE TRANSMISSIONI hereby certify that this correspondence is being transmitted by facsimile to fax
number 571-273-8300 to the U.S. Patent and Trademark Office. Attention
Examiner Lan Vinh on August 28, 2007.Signed: 

Mary Terry

INFORMATION DISCLOSURE STATEMENT
37 CFR §§1.56 AND 1.97(b)Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The reference(s) identified in the attached PTO Form 1449 (copies of non-U.S. references are attached) may be material to examination of the above-identified patent application. Applicants identify these reference(s) in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make the identified reference(s) of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that the identified reference(s) indeed constitute prior art.

This Information Disclosure Statement is being filed after the mailing date of the first Office Action on the merits, or after three months from the filing date of this application, whichever event occurred last, but it is believed before the mailing date of either: (i) a final action under §1.113 or (ii) a notice of allowance under §1.311, whichever occurs first.

Docket No. NOVLP068/NVLS-2818

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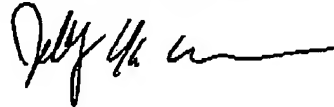
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Accompanying this Information Disclosure Statement is the fee set forth in 37 CFR
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☒ The Commissioner is authorized to charge \$180.00 in payment of the Information
Disclosure Statement Fee. If it is determined that any additional fees are due, the Commissioner
is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP068).

Respectfully submitted,
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Docket No.: NOVLP068/NVLS-2818

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| Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary) | Atty Docket No. | Application No.: |
| | NOVLP068/NVLS-2818 | 10/690,084 |
| | Applicant: | |
| | Koos et al. | |
| | Filing Date | Group |
| | October 20, 2003 | 1765 |

U.S. Patent and Publication Documents

| Examiner Initial | No. | Patent No. | Date | Patentee | Class | Sub-class | Filing Date |
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Foreign Patent or Published Foreign Patent Application

| Examiner Initial | No. | Document No. | Publication Date | Country or Patent Office | Class | Sub-class | Translation | |
|------------------|-----|--------------|------------------|--------------------------|-------|-----------|-------------|----|
| | | | | | | | Yes | No |
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Other Documents

| Examiner Initial | No. | Author, Title, Date, Place (e.g. Journal) of Publication |
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| | C1 | |
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| Examiner | | Date Considered |

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.